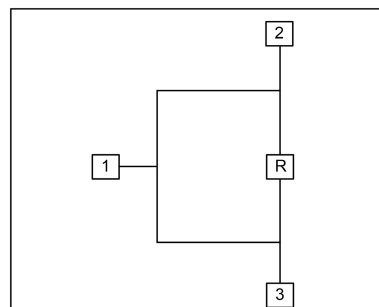


## GaAs MMIC Monolithic Integrated 0 Degree Power Divider, 18-26GHz

### Performance characteristics

- Frequency range: 18-26GHz
- Insertion loss : 0.4 dB
- 50Ohm input / output
- 100% on-wafer testing
- Chip size: 1.8 x 1.2 x 0.1mm

### Functional Block Diagram



### Product Introduction

The GPD-1826 monolithic integrated 0-degree power divider has low insertion loss and excellent port standing wave characteristics in the frequency range of 18 ~ 26GHz, with an isolation of 24 dB, and is very suitable for microwave hybrid integrated circuits and multi-chip modules. The chip uses on-chip through-hole metallization technology to ensure good grounding, does not require additional grounding measures, and is simple and convenient to use.

#### Use restriction parameter <sup>1</sup>

Maximum input power	+40dBm
Operating temperature	-55 ~ +85°C
storage temperature	-65 ~ +150°C

【1】 Exceeding any of these maximum limits may cause permanent damage.

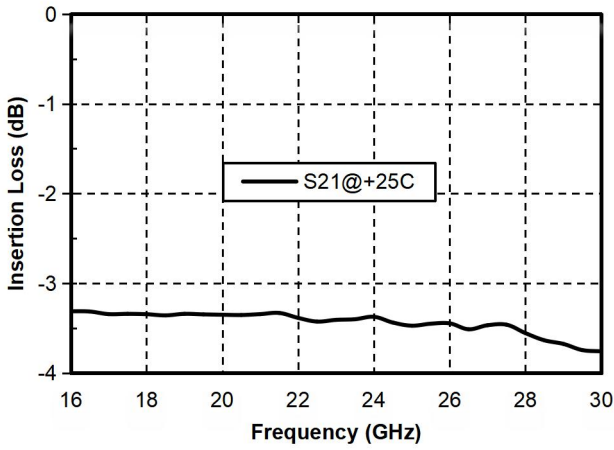
#### Electrical performance parameters ( TA = +25°C)

index	Minimum	Typical Value	Maximum	unit
Frequency Range	18-26			GHz
Insertion loss	0.3	0.4	0.5	dB
Insertion loss fluctuation		± 0.1		dB
Isolation	18	24	-	dB
Input return loss	17	22	-	dB
Output return loss	twenty one	25	-	dB

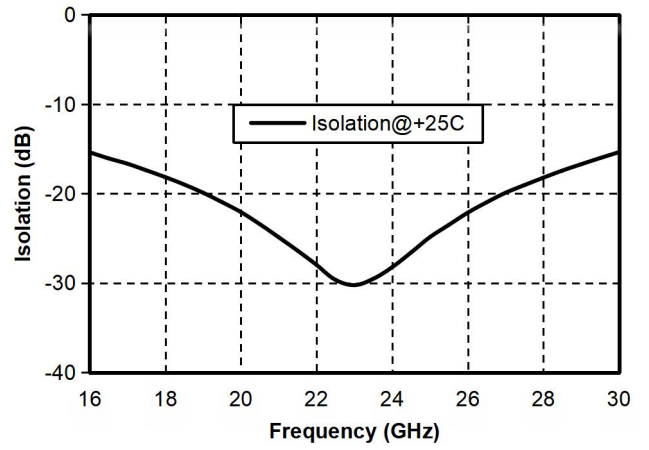
## GaAs MMIC Monolithic Integrated 0 Degree Power Divider, 18-26GHz

Main index test curve

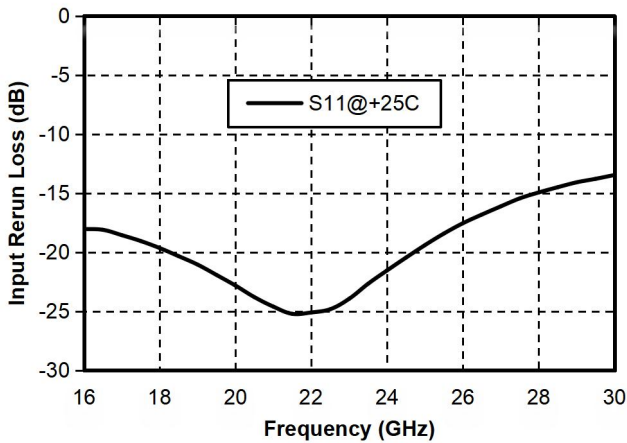
Insertion Loss vs. Operating Frequency



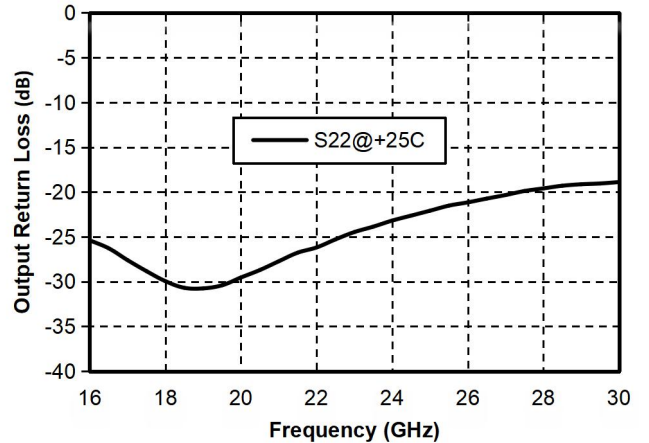
Isolation vs. Operating Frequency



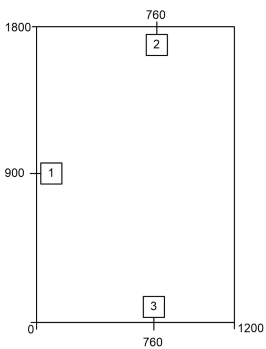
Input Return Loss vs. Operating Frequency



Output Return Loss vs. Operating Frequency






Appearance structure <sup>2</sup>

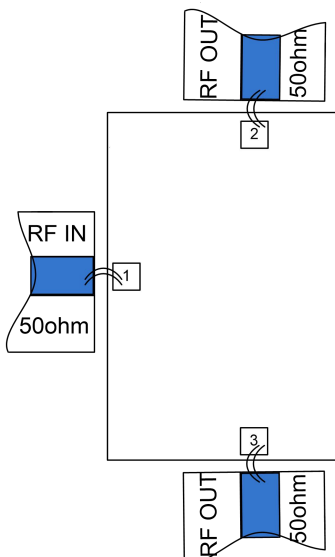


【 2 】 All units in the figure are micrometers

## GaAs MMIC Monolithic Integrated 0 Degree Power Divider, 18-26GHz

Bonding point definition				
Bonding number	point	Function Symbol	Functional Description	Equivalent Circuit
1		RF IN	RF signal input terminal	RF IN 
2,3		RF OUT	RF signal output terminal	 RF Out
Chip bottom		GND	The bottom of the chip needs to be well grounded to RF and DC	

### Recommended assembly drawing



### Precautions for use

- The chip needs to be stored in an anti-static container and kept in a nitrogen environment.
- Do not attempt to clean the bare die surface using wet chemical methods.
- Please strictly comply with ESD protection requirements to avoid electrostatic damage to bare chips.
- General operation: Please use precision pointed tweezers to pick up bare chips. Avoid touching the chip surface with tools or fingers during operation.
- Rack mounting operation suggestions: Bare chip mounting can be done by AuSn solder eutectic sintering or conductive adhesive bonding. The mounting surface must be clean and flat.
- Sintering process: It is recommended to use AuSn solder sheets with a gold-tin ratio of 80/20 . The working surface temperature reaches 255 °C and the tool ( vacuum chuck ) temperature reaches 265 °C. When the high-temperature mixed gas (nitrogen-hydrogen ratio of 90/10 ) is blown to the chip, the temperature at the top of the tool should be raised to 290 °C. Do not let the chip exceed 320 °C for more than 20 seconds. The friction time should not exceed 3 seconds.

- Bonding process: The amount of conductive glue dispensed should be as small as possible. After the chip is placed in the installation position , the conductive glue should be vaguely visible around it . For curing conditions, please follow the information provided by the conductive glue manufacturer.
- Bonding operation suggestions: Use  $\Phi 0.025\text{mm}$  (1mil) gold wire for both ball and wedge bonding. Thermo-ultrasonic bonding temperature is  $150\text{ }^{\circ}\text{C}$ . The pressure of the wedge for ball bonding is  $40\sim 50\text{gf}$  , and the pressure of the wedge bonding is  $18\sim 22\text{gf}$  . Use the smallest possible ultrasonic energy. The bonding starts at the pressure point on the chip and ends at the package (or substrate) .